

Attorney Docket # 5300-17



MS-AF
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Neil S CASA

Serial No.: 10/007,618

Filed: November 7, 2001

For: System And Method For Inhibiting Motion Of
Semiconductor Wafers In A Variable-Pressure
Chamber

Examiner: Thuy Van TRAN
Group Art: 3652

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Thomas Langer

Name of applicant, assignee or Registered Representative

Thomas Langer
Signature

February 21, 2006

Date of Signature

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P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

SIR:

RESPONSE

A Notice of Appeal was filed in this application on December 22, 2005. Please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks/Arguments begin on page 10 of this paper.